

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Takeshi SAKAMOTO et al.)	Confirmation No.: 8322
)	
U.S. Application No.: 10/594,907)	Group Art Unit: 2895
)	
Filed: August 7, 2008)	Examiner: Michael Jung
)	
For: LASER PROCESSING METHOD AND)	
SEMICONDUCTOR CHIP)	

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Alexandria, VA 22314

Sir:

RESPONSE TO RESTRICTION/ELECTION REQUIREMENT

In an Office Action dated November 5, 2009, the period for response to which runs through December 7, 2009 (December 5, 2009 being a Saturday), the Examiner required election under 35 U.S.C. § 121 and 372 between the claims of Group I (claims 1-15) allegedly drawn to “a laser processing method” and Group II (claims 16-19) allegedly drawn to “a semiconductor chip.”

Applicants hereby elect Group I (claims 1-15) for examination.

Applicants respectfully request formal examination of this application.

Applicants respectfully submit that no fee is due in connection with the filing of this response. However, if there are any fees due in connection with the filing of this response, **except** for issue fees payable under 37 C.F.R. § 1.18, the Commissioner is hereby authorized by this paper to charge any such fees during the entire pendency of this application, including fees

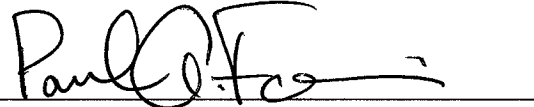
due under 37 C.F.R. §§ 1.16 and 1.17 which may be required and including any required extension of time fees, *or* credit any overpayment to Deposit Account No. 50-0573. This paragraph is intended to be a **CONSTRUCTIVE PETITION FOR EXTENSION OF TIME** in accordance with 37 C.F.R. § 1.136(a)(3).

Respectfully submitted,

DRINKER, BIDDLE & REATH LLP

Dated: December 7, 2009

By:



Paul A. Fournier

Registration No. 41,023

Customer No. 055694

DRINKER, BIDDLE & REATH LLP

1500 K Street, N.W., Suite 1100

Washington, D.C. 20005-1209

Tel: (202) 842-8800

Fax: (202) 842-8465